

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Naoto Horiguchi**

Serial Number: **Not Yet Assigned**

Filed: **February 2, 2004**

For: **SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME**

Attorney Docket No. 042073

Customer No.: 38834

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

February 2, 2004

Sir:

In compliance with 37 CFR 1.56, Applicant calls to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449.

A copy of each of the references is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge

Deposit Account No. 50-2866.

Respectfully submitted,
WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP



Stephen G. Adrian
Reg. No. 32,878

1250 Connecticut Avenue, N.W., Suite 700
Washington, D.C. 20036
Tele: (202) 822-1100
Fax: (202) 822-1111
SGA/yap
Enclosures: PTO-1449; References (5)

**INFORMATION
DISCLOSURE
STATEMENT
PTO-1449**

Atty. Docket No. 042073	Serial No. New Appln.
Applicant(s): Naoto Horiguchi	
Filing Date: February 2, 2004	Group Art Unit:

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA AB					

FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Translation (Yes or No)
_____	AC			
_____	AD			
_____	AE			
_____	AF			

OTHER DOCUMENTS

_____	AG	Patent Abstracts of Japan, Publication No. 05267331, dated October 15, 1993.
_____	AH	Patent Abstracts of Japan, Publication No. 06224381, dated August 12, 1994.
_____	AI	Patent Abstracts of Japan, Publication No. 06338591, dated December 6, 1994.
_____	AJ	Patent Abstracts of Japan, Publication No. 11163157, dated June 18, 1999.
_____	AK	Patent Abstracts of Japan, Publication No. 2000196077, dated July 14, 2000.
Examiner _____		Date Considered _____